

Notice of References Cited

Application/Control No.

09/668,974

Applicant(s)/Patent Under
Reexamination
HELMAN, DANIEL RICHARD

Examiner





Tom Y Lu

Art Unit

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	A	US-5,485,213 A	01-1996	Murashita et al.	375/240.12
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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